

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Akira IZUMI

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For: SUBSTRATE PROCESSING METHOD AND SUBSTRATE PROCESSING  
APPARATUS

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Examiner: Kin Chan CHEN

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Commissioner for Patents

P.O. Box 1450

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**INFORMATION DISCLOSURE STATEMENT AFTER ALLOWANCE**

Sir:

Enclosed please find a copies of prior art together with a form listing the same for the convenience of the Examiner. The present Information Disclosure Statement is being submitted after receipt of a Notice of Allowance, but before payment of the Issue Fee.

I certify that each item of information contained in the present Information Disclosure Statement, to the best of applicant's knowledge, was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to filing the present Statement. The fee of **\$180.00** for filing the present Information Disclosure Statement subsequent to a Notice of Allowance, but before payment of the Issue Fee is also submitted electronically herewith.

In the event the actual fee is greater than the payment submitted or is inadvertently not enclosed or if any additional fee due during the pendency of this application is not paid, the patent and Trademark Office is authorized to charge the underpayment to Deposit Account No. 15-0700.

Respectfully submitted,

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